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Substitute for form: 1449A/PTO	Complete if Known
	Application Number
INFORMATION DISCLOSURE	Filing Date 03/30/2004
STATEMENT BY APPLICANT	First Named Inventor Rupich, Martin W.
	ArtUnit
(Use as many sheets as necessary)	Examiner Name
igcep Sheet $igcep$ of $igcep$ 2	Attorney Docket Number 2802/169US1 AMSC-662

				U. S. PATENT I	DOCUMENTS	
Examiner Initials*	Cite No.1	Number-	Iment Number -Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-	6,440,211	08/27/2002	David Beach et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	16
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Substitute for form 1449B/PTO	Complete if Known
	Application Number
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STATEMENT BY APPLICANT	First Named Inventor Rupich, Martin W.
	Art Unit
(Use as many sheets as necessary)	Examiner Name
Sheet 2 of 2	Attorney Docket Number 2802 169US1 AMSC 662

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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